

OSMM&N File No. 245683US0CONT

Serial No. 10/718,574

In the matter of the Application of: Hitoshi MORINAGA, et al.

For: METHOD FOR CLEANING A SURFACE OF A SUBSTRATE

De: C

By: NFO/HAP/scs

Due Date: N/A

The following has been received in the U.S. Patent Office on the date stamped her

- Dep. Acct. Order Form
- PTO Cover Letter
- Comments on Statement of Reasons for Allowance



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Docket No.: 245683US0CONT

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SPIVAK
McCLELLAND
MAIER
&
NEUSTADT
P.C.

ATTORNEYS AT LAW

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

RE: Application Serial No.: 10/718,574

Applicants: Hitoshi MORINAGA, et al.

Filing Date: November 24, 2003

For: METHOD FOR CLEANING A SURFACE OF A
SUBSTRATE

Group Art Unit: 1746

Examiner: CHAUDHRY, S.T.

SIR:

Attached hereto for filing are the following papers:

Comments on Statement of Reasons for Allowance

Our check in the amount of -0- is attached covering any required fees. In the event any variance exists between the amount enclosed and the Patent Office charges for filing the above-noted documents, including any fees required under 37 C.F.R. 1.136 for any necessary Extension of Time to make the filing of the attached documents timely, please charge or credit the difference to our Deposit Account No. 15-0030. Further, if these papers are not considered timely filed, then a petition is hereby made under 37 C.F.R. 1.136 for the necessary extension of time. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

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Norman F. Oblon

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DOCKET NO: 245683US0CONT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :
HITOSHI MORINAGA, ET AL. : EXAMINER: CHAUDHRY, S. T.
SERIAL NO: 10/718,574 :
FILED: NOVEMBER 24, 2003 : GROUP ART UNIT: 1746
FOR: METHOD FOR CLEANING A :
SURFACE OF A SUBSTRATE :

COMMENTS ON STATEMENT OF REASONS FOR ALLOWANCE

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

The Examiner's statement of reasons for allowance refers to unexpected results with respect to Example 9.

Applicants made the following argument at page 11 of the amendment filed December 28, 2004:

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The efficacy of the present inventions is demonstrated by the comparative data in the specification and its superiority to the methods of the above-discussed prior art. Compare, for example, Example 13 and Comparative Example 9, described in the specification beginning at page 50, line 7, wherein both t and C are within the terms of the present Claim 1 but the relationship $0.25 \leq tC^{1.29} \leq 5$ is satisfied for Example 9 but not satisfied for Comparative Example 9. As Table 3 at page 51 of the specification indicates, etching was good for Example 9 but bad for Comparative Example 9. Thus, contrary to the suggestion made by the Examiner during the above-referenced interview, the above relationship is not necessarily satisfied, even if t and C are satisfied.

Thus, Applicants relied on a comparison of Example 13 to Comparative Example 9, but inadvertently later on in the paragraph referred to Example 9 instead of Example 13. In

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Comments on Statement of Reasons for Allowance

other words, Applicants intended to rely, and still rely, on a comparison between Example 13 and Comparative Example 9, not Example 9 and Comparative Example 9.

Respectfully submitted,

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OSMM&N File No. 245683US0CONT
Serial No. 10/718,574

Dept.: IP-I
By: NFO/ims

In the matter of the Application of: Hitoshi MORINAGA, et al.
For: METHOD FOR CLEANING A SURFACE OF A SUBSTRATE

Due Date: N/A

The following has been received in the U.S. Patent Office on the date stamped hereon:

Request for Priority Priority Doc (1)



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Docket No.: 245683US0CONT/smc

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Hitoshi MORINAGA, et al.

SERIAL NUMBER: 10/718,574 GROUP: 1746

FILED: November 24, 2003 EXAMINER: CHAUDHRY, SAEED T

FOR: METHOD FOR CLEANING A SURFACE OF A SUBSTRATE

REQUEST FOR PRIORITY ACKNOWLEDGMENT

MAIL STOP ISSUE FEE
COMMISSIONER FOR PATENTS
P.O. BOX 1450
ALEXANDRIA, VA 22313-1450

SIR:

In the matter of the above-identified application we hereby request acknowledgment of the priority papers filed March 1, 2004, as evidenced by the enclosed copies of the date-stamped filing receipt, the Request for Priority and the first 3 pages of the Priority Document(s).

Respectfully Submitted,

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